

**Search Notes**

Application/Control No.

09/778,627

Examiner

David Y. Chung

Applicant(s)/Patent under  
Reexamination

TAKEDA ET AL.

Art Unit

2871


**SEARCHED**

Class	Subclass	Date	Examiner
349	129	4/2/2003	DC
349	130	4/2/2003	DC
349	123	4/2/2003	DC
updated	updated	4/3/2005	DC
349	139	4/3/2005	DC
349	143	4/3/2005	DC

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
same	same	4/3/2005	DC

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
EAST search report	4/2/2003	DC
Consulted Ken Parker 	3/31/2005	DC
EAST search report	4/3/2005	DC